

INFORMATION DISCLOSURE STATEMENT PTO-1449	Atty. Docket No. 030744	Serial No. New Application
	Applicant(s): Mutsumi YANO, et al.	
	Filing Date: July 3, 2003	Group Art Unit: Not Yet Assigned

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA	/				
_____	AB					
_____	AC					
_____	AD					

FOREIGN PATENT DOCUMENTS

Document No.	Date	Country	Translation (Yes or No)	
<input checked="" type="checkbox"/> AE	5-121275	05/18/93	Japan	Yes-Abstract/Discussed in the specification
<input checked="" type="checkbox"/> AF	11-312628	11/09/99	Japan	Yes-Abstract/Discussed in the specification
_____ AG	/			
_____ AH				
_____ AI				

OTHER DOCUMENTS

<input checked="" type="checkbox"/>	AJ	G.E. Thompson et al.; "The Migration of Fluoride Ions in Growing Anodic Oxide Films on Tantalum"; <i>Journal Electrochemical Society</i> ; Vol. 144; No. 2; pp. 418-423, February, 1997.	
_____	AK		
Examiner	<i>Jim [Signature]</i>	Date Considered	6/16/04